

## Electronic Patent Application Fee Transmittal

|                                      |                                 |  |  |  |
|--------------------------------------|---------------------------------|--|--|--|
| Application Number:                  | 10510389                        |  |  |  |
| Filing Date:                         | 14-Dec-2004                     |  |  |  |
| Title of Invention:                  | Plasma processing system        |  |  |  |
| First Named Inventor/Applicant Name: | Nobuo Ishii                     |  |  |  |
| Filer:                               | Cameron Wade Beddard/Cathy Ryan |  |  |  |
| Attorney Docket Number:              | 101248.55500US                  |  |  |  |

Filed as Large Entity

### U.S. National Stage under 35 USC 371 Filing Fees

| Description | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|-------------|----------|----------|--------|----------------------|
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Basic Filing:

Pages:

Claims:

Miscellaneous-Filing:

Petition:

Patent-Appeals-and-Interference:

Post-Allowance-and-Post-Issuance:

Extension-of-Time:

|                                   |      |   |     |     |
|-----------------------------------|------|---|-----|-----|
| Extension - 1 month with \$0 paid | 1251 | 1 | 120 | 120 |
|-----------------------------------|------|---|-----|-----|

| Description                       | Fee Code | Quantity | Amount | Sub-Total in USD(\$) |
|-----------------------------------|----------|----------|--------|----------------------|
| <b>Miscellaneous:</b>             |          |          |        |                      |
| Request for continued examination | 1801     | 1        | 810    | 810                  |
| <b>Total in USD (\$)</b>          |          |          |        | <b>930</b>           |